

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Peter W. Gaudet, Donald A. Olsen, Michael J. Eacobacci and John T. Harvell
Application No.: 10/750,565 Group Art Unit: 3744
Filed: December 31, 2003 Examiner: Not assigned
Confirmation No.: 5725
Title: Electronically Controlled Vacuum Pump Gauge

| CERTIFICATE OF MAILING OR TRANSMISSION | |
|---|---------------------|
| I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or is being facsimile transmitted to the United States Patent and Trademark Office on: | |
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INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement is submitted:

☐ under 37 CFR 1.129(a), or

(First/Second submission after Final Rejection)

☒ under 37 CFR 1.97(b), or

(Within any one of the following time periods: three months of filing national application (other than a CPA) or date of entry of the national stage in an international application; or before the mailing date of a first office action on the merits in a non-provisional application, including a CPA, or a Request for Continued Examination).

☐ under 37 CFR 1.97(c) together with either:

☐ a Statement under 37 CFR 1.97(e), as checked below, or

☐ a \$180.00 fee under 37 CFR 1.17(p), or

(After the 37 CFR 1.97(b) time period, but before final action or notice of allowance, whichever occurs first)

☐ under 37 CFR 1.97(d) together with:

☐ a Statement under 37 CFR 1.97(e), as checked below, and

☐ a \$180.00 fee under 37 CFR 1.17(p), or

(Filed after final action or notice of allowance, whichever occurs first, but on or before payment of the issue fee)

☐ under 37 CFR 1.97(i):

Applicant requests that the IDS and cited reference(s) be placed in the application filewrapper.

(Filed after payment of issue fee)

Statement Under 37 CFR 1.97(e)

- ☐ Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement; or
- ☐ No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned, after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of this Information Disclosure Statement.

Statement Under 37 CFR 1.704(d) (Patent Term Adjustment)

Applies to original applications (other than design) filed on or after May 29, 2000

- ☐ Each item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application and this communication was not received by any individual designated in § 1.56(c) more than thirty days prior to the filing of the Information Disclosure Statement.
- ☒ Enclosed herewith is form PTO-1449:
 - ☒ Copies of the cited references are enclosed.
 - ☒ Since this application was filed after June 30, 2003, copies of issued U.S. patents and published U.S. applications are not required and are not being provided.
 - ☐ Copies of the cited references are enclosed except those entered in prior application, U.S. Application No. [], to which priority under 35 U.S.C. 120 is claimed. [The earlier application contains copies of the cited references.]
 - ☐ The listed references were cited in the enclosed International Search Report in a counterpart foreign application.
 - ☒ The "concise explanation" requirement (non-English references) for reference(s) AN & AO under 37 CFR 1.98(a)(3) is satisfied by:
 - ☐ the explanation provided on the attached sheet.
 - ☐ the explanation provided in the Specification.
 - ☐ submission of the enclosed International Search Report.
 - ☐ submission of the enclosed English-language version of a foreign Search Report and/or foreign Office Action.
 - ☒ the enclosed English language abstract.

☐ Applicant requests that the following non-published pending applications be considered:

Examiner's
Initials

_____ U.S. Patent Application No. [], by [inventor(s)], filed [], Docket No.: []

_____ U.S. Patent Application No. [], by [inventor(s)], filed [], Docket No.: []

_____ U.S. Patent Application No. [], by [inventor(s)], filed [], Docket No.: []

Examiner

Date

☐ A copy of each above-cited application, including the current claims, is enclosed.

☐ A copy of each above-cited application, including the current claims, is enclosed, except those entered in prior application, U.S. Application No. [], to which priority under 35 U.S.C. 120 is claimed.

The Examiner is requested to return a copy of the above list of pending applications indicating which references were considered with the next office communication.

It is requested that the information disclosed herein be made of record in this application.

Method of payment:

☐ A check for the fee noted above is enclosed, or the fee has been included in the check with the accompanying Reply. A copy of this Statement is enclosed.

☐ Please charge Deposit Account 08-0380 in the amount of \$[]. A copy of this Statement is enclosed.

☒ Please charge any deficiency in fees and credit any overpayment to Deposit Account 08-0380.

Respectfully submitted,

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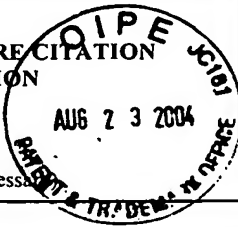
Dated: 8-20-04

PTO-1449 REPRODUCED

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

August 20, 2004

(Use several sheets if necessary)

ATTORNEY DOCKET NO.
0100.1361-026APPLICATION NO.
10/750,565FIRST NAMED INVENTOR
Peter W. GaudetFILING DATE
12/31/03EXAMINER
N/ACONFIRMATION NO.
5725GROUP
3744

U.S. PATENT DOCUMENTS

| EXAM- INER INI- TIAL | REF. NO. | DOCUMENT NUMBER Number-Kind Code (if known) | ISSUE DATE / PUBLICATION DATE MM-DD-YYYY | NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT |
|-------------------------------|-------------|--|--|--|
| | AA | 4,354,356 | 10-19-1982 | Milner |
| | AB | 4,361,418 | 11-30-1982 | Tscheppe |
| | AC | 4,412,851 | 11-01-1983 | Laine |
| | AD | 4,438,632 | 03-27-1984 | Lessard, <i>et al.</i> |
| | AB | 4,546,613 | 10-15-1985 | Eacobacci, <i>et al.</i> |
| | AF | 4,602,642 | 09-25-1990 | O'Hara, <i>et al.</i> |
| | AG | 4,614,093 | 09-30-1986 | Bachler, <i>et al.</i> |
| | AH | 4,633,672 | 01-06-1987 | Persem, <i>et al.</i> |
| | AI | 4,667,477 | 05-26-1987 | Matsuda, <i>et al.</i> |
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| | AK | 4,688,261 | 08-18-1987 | Killoway, <i>et al.</i> |
| | AA2 | 4,724,677 | 02-16-1988 | Foster |
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| | AC2 | 4,829,774 | 05-16-1989 | Wassibauer, <i>et al.</i> |
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| | AE2 | 4,926,648 | 05-22-1990 | Okumura, <i>et al.</i> |
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| | AA3 | 5,157,928 | 10-27-1992 | Gaudet, <i>et al.</i> |
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| | AD3 | 5,323,465 | 06-21-1994 | Avarne |

EXAMINER

DATE CONSIDERED

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(Use several sheets if necessary)

FIRST NAMED INVENTOR
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EXAMINER
N/A

FILING DATE
12/31/03

CONFIRMATION NO.
5725

GROUP
3744

U.S. PATENT DOCUMENTS

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EXAMINER

DATE CONSIDERED

| | | | |
|---|--|--------------------------------------|--------------------------------|
| PTO-1449 REPRODUCED INFORMATION DISCLOSURE CITATION IN AN APPLICATION August 20, 2004 (Use several sheets if necessary) | ATTORNEY DOCKET NO. 0100.1361-026 | APPLICATION NO. 10/750,565 | |
| | FIRST NAMED INVENTOR Peter W. Gaudet | | FILING DATE 12/31/03 |
| | EXAMINER N/A | CONFIRMATION NO. 5725 | GROUP 3744 |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER Country Code-Number-Kind Code (if known) | DATE MM-DD-YYYY | NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT | TRANSLATION YES NO | |
|--|-----|--|--------------------|--|-----------------------|--|
| | AL | CH 652 804 A5 | 11-29-1985 | Balzers Aktiengesellschaft | | |
| | AM | GB 2 065 782 | 07-01-1981 | Leybold-Heraeus GmbH | | |
| | AN | JP 403107599 | 05-07-1991 | NTN Corp. | | |
| | AO | JP 403182698 | 08-08-1991 | Seiko Seiki Co. Ltd. | | |
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| | AL3 | | | | | |
| | AM4 | | | | | |
| | AN4 | | | | | |
| | AO3 | | | | | |
| | AP3 | | | | | |
| | AQ3 | | | | | |
| | AL4 | | | | | |
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| | AO4 | | | | | |
| | AP4 | | | | | |
| | AQ4 | | | | | |

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GROUP
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AW2

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AX2

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DATE CONSIDERED

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|--|---|--|-------------------------------|---------------|
| PTO-1449 REPRODUCED INFORMATION DISCLOSURE CITATION IN AN APPLICATION August 20, 2004 (Use several sheets if necessary) | ATTORNEY DOCKET NO. 0100.1361-026 | | APPLICATION NO. 10/750,565 | |
| | FIRST NAMED INVENTOR Peter W. Gaudet | | FILING DATE 12/31/03 | |
| | EXAMINER N/A | | CONFIRMATION NO. 5725 | GROUP 3744 |

| OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) | | |
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| AS | Finley, "Automatic regeneration of multiple cryopumps," <u>J. Vac. Sci. Technology</u> , A4(3), May/June 1986, pp. 310-313. | |
| AT | Temescal product description, September 1982. | |
| AU | Peterson, John F., "Cryopump Regeneration for Optimized Uptime," <u>Solid State Technology</u> , April 1986, pp. 199-201. | |
| AV | Longworth, R.C., et al., "Cryopump regeneration studies," <u>J. Vac. Sci. Technology</u> , 21(4), Nov./Dec. 1982, pp. 1022-1027. | |
| AW | Peterson, John F. et al., "Vacuum Pump Technology; A Short Course on Theory and Operations," <u>Solid State Technology</u> , January 1982, pp. 104-110. | |
| AX | Sievert, Reinhard, "Regenerating Refrigerator-Cryopumps Cooled," <u>Solid State Technology</u> , May 1986, pp. 90-92. | |
| AY | Singer, Peter H., "Update on Cryogenic Pumps," <u>Semiconductor International</u> , October 1982, pp. 89-99. | |
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| EXAMINER | DATE CONSIDERED |
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